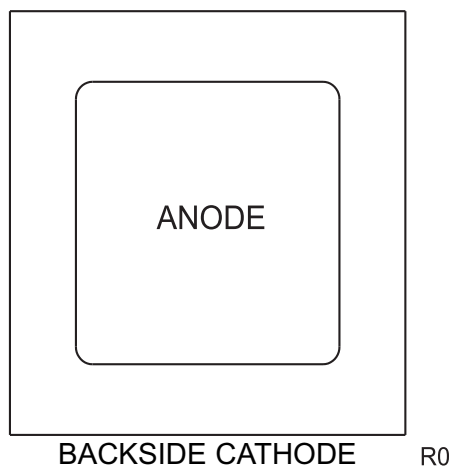


**PROCESS DETAILS**

Process	EPITAXIAL PLANAR
Die Size	14 X 14 MILS
Die Thickness	7.5 MILS
Anode Bonding Pad Area	7.5 X 7.5 MILS
Top Side Metalization	Al - 13,000Å TYP
Back Side Metalization	Au - 14,000Å TYP

**Geometry**



**GROSS DIE PER 4 INCH WAFER**

61,141

**PRINCIPAL DEVICE TYPES**

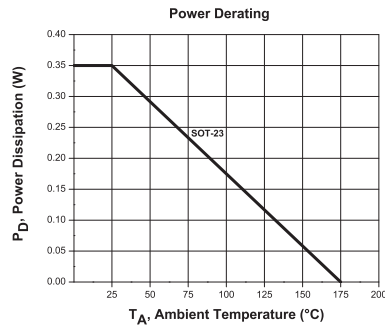
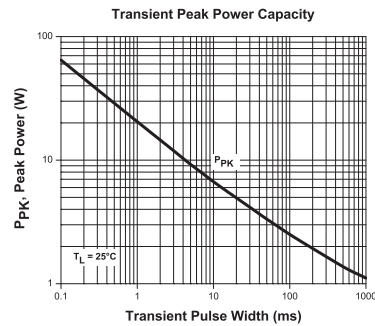
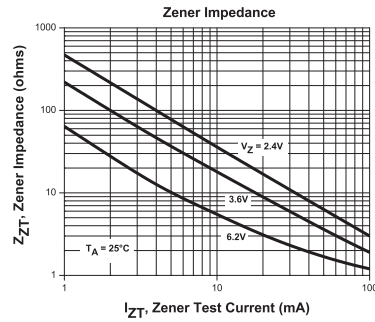
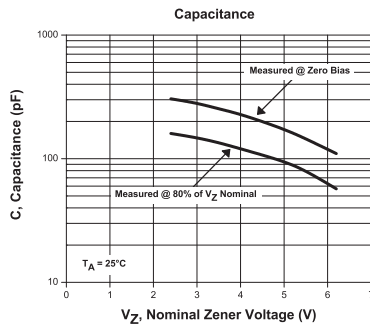
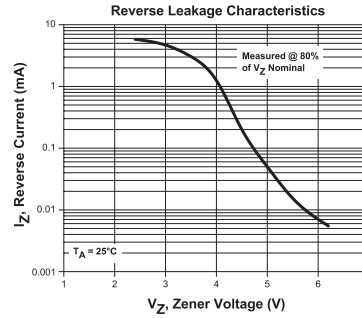
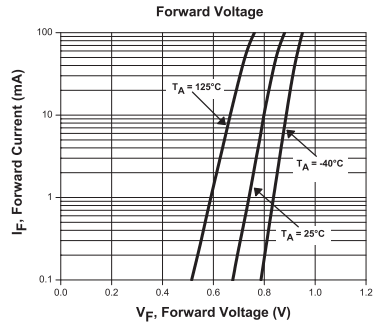
CMPZ5221B

THRU

CMPZ5234B

145 Adams Avenue  
Hauppauge, NY 11788 USA  
Tel: (631) 435-1110  
Fax: (631) 435-1824  
www.centalsemi.com

R4 (9-January 2009)



145 Adams Avenue  
Hauppauge, NY 11788 USA  
Tel: (631) 435-1110  
Fax: (631) 435-1824  
www.centralsemi.com

R4 (9-January 2009)